1 P Appl. No. 10/624,716

MAY 1 6 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

<i>[</i> .]	
Application Serial No	10/624,716
Hing Date	
	Luan C. Tran
	Micron Technology, Inc.
	2812
	Kennedy, Jennifer M.
	MI22-2357
	021567
Title.	Methods of Forming Semiconductor Constructions

RESPONSE TO FEBRUARY 23, 2005 OFFICE ACTION

To:

Mail Stop Amendment Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

From:

Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)

Wells St. John P.S.

601 W. First Avenue, Suite 1300 Spokane, WA 99201-3828

AMENDMENTS

Introductory Comments

In reply to the Office Action of February 23, 2005, applicant amends and remarks as follows.